

Notice of References Cited	Application/Control No. 10/789,744		Applicant(s)/Patent Under Reexamination HO, WAI YUEN	
	Examiner LEONARD S. LIANG		Art Unit 2853	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-			
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FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Official Translation of Okada et al (JP Pat 200104799 A) (cited as Kushino et al in final rejection of 02/09/09; Kushino and Okada are co-inventors)
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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